P30044.P01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Sakae KOYATA et al.,

Group Art Unit: Not yet assigned

Appl. No.

: Not yet assigned

Examiner: Not yet assigned

Filed

: Concurrently herewith

Confirmation No.: Not yet assigned

For

: METHOD FOR MANUFACTURING SINGLE-SIDE MIRROR

SURFACE WAFER

AUTHORIZATION TO CHARGE DEPOSIT ACCOUNT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir:

The undersigned hereby authorizes the U.S. Patent and Trademark Office to charge any fees necessary to maintain the pendency of the above-identified application, including any basic filing fees, application size fees, search fees, examination fees, extension of time fees, and claim fees, to Deposit Account No. 19-0089.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted, Sakae KOYATA et al.,

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